

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KWAN et al.

Application No.: 10/648,270

Filed: August 27, 2003

Title: POSITIONING SYSTEM FOR USE IN LITHOGRAPHIC APPARATUS



Confirmation No. 5209

Group Art Unit: 2881

Examiner: UNKNOWN

December 12, 2003

**INFORMATION DISCLOSURE STATEMENT**

Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. The undersigned respectfully notes that copies of U.S. references are not required in applications filed after June 30, 2003.

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

U.S. Patent No. 4,655,594, also cited in the Search Report, was already submitted for consideration by the Examiner on August 27, 2003.

Respectfully submitted,

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Atty. Dkt. No.	M#	Client Ref.
	305336	P-0158.011-US

**INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT**

Applicant: KWAN et al.

Appln. No.: 10/648,270

Filing Date: August 27, 2003

Date: December 12, 2003 Page 1 of 1

Examiner: Group Art Unit:

**U.S. PATENT DOCUMENTS**

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR	5,760,564	06/1998	NOVAK			
	BR	5,874,820	02/1999	LEE			
	CR						
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						
	MR						
	NR						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date MM/YYYY	Country	Inventor Name		Abstract		Readily Available	
							Enclosed	No	Enclose	No
	OR									
	PR									
	QR									
	RR									
	SR									
	TR									
	UR									
	VR									
	WR									
	XR									

**OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

	YR									
	ZR									
	AAR									
	BBR									
	CCR									
	DDR									
	EER									

Examiner Date Considered:

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.